

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) **CONFIRMATION NO.: 2876**

Shingo HISHIYA)

U.S. Serial No.: 10/554,086)

Group Art Unit: 1792

Filed: October 21, 2005)

Examiner: Brett P. Chen

For: SURFACE MODIFICATION METHOD FOR INTERLAYER INSULATING FILM (as amended)

AMENDMENT PURSUANT TO RULE 111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mailstop: Amendment

Sir :

In response to the first non-final Office Action mailed in the above-captioned patent application on November 5, 2008, please amend the above-identified application and consider the following remarks.

Amendments to the Specification begin on Page 2 of this paper.

Amendments to the Claims begin on Page 3 of this paper.

Remarks begin on Page 6 of this paper.

Substitute Abstract begin on Page 10 of this paper.

This Amendment is being filed with a request for a two-month extension of time and the requisite fee such that the time period for response is believed to expire on April 5, 2009.

Consequently, the Amendment is believed to be timely filed.